

**LAMINATED PIEZOELECTRIC ELEMENT, ACTUATOR  
AND PRINTING HEAD**

**BACKGROUND OF THE INVENTION**

5    1. Field of the Invention

The present invention relates to a laminated piezoelectric element, an actuator and a printing head and, more particularly, to a laminated piezoelectric element and an actuator that are suitable for the piezoelectric sensor of, for example, fuel injector, ink jet printer, piezoelectric resonator, oscillator, ultrasonic motor, ultrasonic oscillator, filter, acceleration 10 sensor, knocking sensor, AE sensor or the like, and can be advantageously used particularly for a printing head that utilizes vibration of 2-dimensional vibration of expansion and contraction or linear vibration in longitudinal direction or in the direction of the thickness.

15    2. Description of Related Art

Piezoelectric ceramics materials have been used in, for example, actuator, filter, piezoelectric resonator (oscillator included), ultrasonic oscillator, ultrasonic motor and piezoelectric sensor.

Among these devices, the piezoelectric actuator is used as the positioning actuator 20 for an X-Y stage of semiconductor manufacturing equipment, the actuator for the printing head of ink jet printer or the like, by making advantage of the very high response of the piezoelectric element to electrical signals, in the order of micro seconds. Especially with the recent trend of color printers toward higher printing speed and lower prices, piezoelectric elements are under increasing demand for the application to the ink 25 discharging actuator of ink jet printer or the like.

For example, Japanese Unexamined Patent Publication No. 11-121820 discloses an actuator that uses a silver-palladium alloy for internal electrode. This actuator is manufactured in such a process as: First, an electrically conductive paste is printed on the surface of a green sheet made of a piezoelectric ceramic material as the major component 5 with a thickness of  $200 \mu\text{m}$  so as to form internal electrodes, 200 green sheets are stacked one on another with the side on which the internal electrodes are printed facing upward, a set of five green sheets without the electrode paste printed thereon is stacked on each side of the stack, on top and bottom, and the resultant stack is pressed to make a laminate. Then the laminate is processed to remove binder contained in the green sheets and in the 10 internal electrodes, and is sintered to make a sintered laminate. An insulator, external electrodes and lead wires are connected to the sintered laminate, thereby to complete the actuator.

The actuator that is made as described above has an advantage that it is easy to make the multi-layer laminate of the piezoelectric ceramic material and the electrode 15 material and that the actuator can be manufactured at a low cost, and therefore has been preferably used as the actuator for the printing head of ink jet printer, the positioning actuator for X-Y stage and the like.

Unfortunately, the actuator disclosed in Japanese Unexamined Patent Publication No. 11-121820 is relatively large in thickness which imposes a limitation to the amount of 20 displacement, resulting in a problem that large displacement cannot be achieved.

Moreover, there is also a problem of deteriorating characteristic of the actuator displacement, thus resulting in a marked decrease in the displacement of the printing head.

In high resolution printers which have been showing remarkable progress recently, in particular, thinner piezoelectric ceramic layers are employed in order to achieve greater 25 displacement of the actuator. In the case of a thin actuator made by stacking piezoelectric

ceramic layers each measuring several tens of micrometers or less in thickness or an actuator having a total thickness of  $100 \mu m$  or less, on the other hand, there is such a problem that shrinkage of the internal electrodes caused during sintering results in significant deformation because the actuator is very thin.

5 There is also such a problem that  $d$  constant varies significantly across a single element, since residual stress is distributed unevenly across the actuator by uneven shrinkage of the internal electrodes. In such a thin actuator as described above, in particular, in case a plurality of displacement elements are mounted on a single circuit board, significant variations beyond  $\pm 10\%$  occur in the amount of displacement among 10 the actuators. It requires an expensive IC to control the operation of the actuators having such significant variations, thus resulting in an increase in the manufacturing cost of the printing head or the printer, while requiring complicated control scheme.

### SUMMARY OF THE INVENTION

15 Accordingly, an object of the present invention is to provide a laminated piezoelectric element and an actuator that are capable of making larger displacement with less variation in the displacement.

Another object of the present invention is to provide a printing head that has a better displacement characteristic and is capable of printing with higher picture quality and 20 higher resolution.

The present inventors have found that, in the case of a laminated piezoelectric element having a thickness larger than  $100 \mu m$ , shrinkage of the electrode occurs in the direction of the thickness thus resulting in less residual stress within the surface since the piezoelectric ceramic layer has a greater thickness compared to that of the electrode, while 25 in the case of a laminated piezoelectric element having a thickness within  $100 \mu m$ ,

shrinkage of the electrode has an influence over the entire laminated piezoelectric element and causes a difference in shrinkage between the electrode and the piezoelectric ceramic layer, thus resulting in a significant residual stress remaining after sintering.

Based on this finding, the present inventors have further studied and reached  
5 another finding that it is made possible to decrease the residual stress in the laminated piezoelectric element and prevent it from deforming by improving the wettability of the paste to form the electrode and the piezoelectric ceramic layer thereby increasing the bonding between these members, so that uniform distribution of the d constant (piezoelectric strain constant) across the actuator surface can be obtained.

10 Specifically, the laminated piezoelectric element having a thickness of  $100 \mu \text{m}$  or less of the present invention comprises a laminate which comprises a plurality of piezoelectric ceramic layers, and electrodes provided at least one of the surface and the inside of said laminate, wherein said electrodes comprises a silver-palladium alloy containing 71 to 99.9% by volume of silver and 0.1 to 29% by volume of palladium. This  
15 laminated piezoelectric element can make a large displacement because of a small thickness, while variations in displacement are small because of reduced residual stress. As a result, the laminated piezoelectric element and the actuator thus obtained allow easy control of displacement and provide stable piezoelectric characteristic.

The electrodes of the laminated piezoelectric element according to the present  
20 invention preferably comprises a silver-palladium alloy that contains 87% by volume or more silver and has residual stress of  $100 \text{ MPa}$  or less remaining inside. When the silver-palladium alloy containing 87% by volume or more silver is used and the firing conditions are controlled, higher effect of reducing the residual stress can be obtained and a laminated piezoelectric element having better displacement characteristic can be made, so that a high  
25 performance printing head can be made when used as an actuator.

The piezoelectric ceramic layer preferably contains Pb, which enables it to improve the wettability between the piezoelectric ceramic layer and the silver-palladium alloy that makes the electrodes.

It is also preferable that the electrodes include piezoelectric ceramic material, and

5 the proportion of the silver-palladium alloy to the piezoelectric ceramic material is in a range from 100: 16 to 60. This constitution further improves the bonding strength between the electrode and the piezoelectric ceramic layer so as to effectively restrict the deformation of the piezoelectric ceramic element and maintain a low electrical conductivity.

10 It is also preferable that the piezoelectric ceramic material has mean crystal grain size of  $0.9 \mu m$  or less, which makes the microscopic structure of the electrodes homogeneous and makes it easier to reduce the residual stress.

Each piezoelectric ceramic layer in the laminated piezoelectric element according to the present invention is preferably in a range from 1 to  $25 \mu m$  in thickness, which

15 makes it possible to increase the displacement of the actuator.

When a voltage is applied between the electrodes, variations in d constant are preferably within  $\pm 10\%$  across the surface, which enables it to use a low-cost IC for controlling the displacement when a plurality of displacement elements are mounted on a single circuit board.

20 In addition, bonding strength between the electrodes and the piezoelectric ceramic layer is preferably 1.25MPa or higher, which makes it easier to maintain stable piezoelectric characteristic.

The actuator of the present invention is characterized in that it is constituted from the laminated piezoelectric element described above, which makes it possible to make the

25 actuator that has high reliability and better piezoelectric characteristic.

It is particularly preferable to join a support member to the bottom surface of the laminated piezoelectric element. This constitution makes it possible to reduce and stabilize variations in displacement.

Specifically, the actuator of the present invention comprises an oscillator plate, 5 internal electrodes provided on the oscillator plate, piezoelectric ceramic layer provided on the internal electrodes and a plurality of surface electrodes provided on the piezoelectric ceramic layer.

The printing head of the present invention comprises a flow passage member in which a plurality of ink compressing chambers having ink nozzles are arranged and the 10 actuator of claim 11 mounted on the flow passage member, the ink compressing chambers and said surface electrodes is aligned with each other. Such a printing head has a better displacement characteristic and is capable of printing with higher picture quality and higher resolution.

Various objects and advantages of the present invention will become apparent in 15 the course of the description, which follows.

#### **BRIEF DESCRIPTION OF THE DRAWINGS**

Fig. 1 is a schematic sectional view showing a laminated piezoelectric element of the present invention.

20 Fig. 2(a) is a schematic sectional view showing a printing head provided with an actuator comprising the laminated piezoelectric element of the present invention, and Fig. 2(b) is a plan view thereof.

Fig. 3 is a schematic sectional view showing a structure for evaluating the laminated piezoelectric element of the present invention.

## DESCRIPTION OF PREFERRED EMBODIMENTS

Now the laminated piezoelectric element and an actuator of the present invention will be described in detail below with reference to the accompanying drawings. Fig. 1 is a sectional view showing the laminated piezoelectric element according to one 5 embodiments of the present invention.

As shown in Fig. 1 the laminated piezoelectric element has a laminate of a plurality of piezoelectric ceramic layers 1 and electrodes provided on the surface and inside of the laminate. The electrodes comprise internal electrode 2 stacked inside of the laminate and a plurality of surface electrodes 3 disposed on the surface of the laminate. 10 Thus a plurality of displacement elements consisting of the surface electrodes 3, the internal electrodes 2 and the piezoelectric ceramic layers 1 that are interposed between the electrodes are formed. The laminated piezoelectric element can be used preferably as an actuator by connecting lead wires to the surface electrodes 3 for the electrical connection with the outside.

15 It is important that a total thickness  $T$  of the laminated piezoelectric element is  $100 \mu m$  or less, preferably  $85 \mu m$  or less and more preferably  $70 \mu m$  or less. This allows it to have a larger displacement of each displacement element and achieve high efficiency in driving the displacement elements with a low voltage.

The thickness  $t$  of the piezoelectric ceramic layer is from 1 to  $25 \mu m$ , preferably 3 20 to  $22 \mu m$ , more preferably from 5 to  $19 \mu m$ , and most preferably from 7 to  $16 \mu m$ , in order to increase the displacement while effectively preventing cracks and breakage from occurring and maintaining the shape.

The thin laminated piezoelectric element having a total thickness of  $100 \mu m$  or less of the prior art has been suffering significant deformation resulting from firing, since 25 the piezoelectric ceramic layer is too thin. Particularly in a laminated piezoelectric

element wherein the thickness of each piezoelectric ceramic layer is  $25 \mu\text{m}$  or less, it has been very difficult to suppress the displacement. Moreover, the residual stress that is distributed unevenly has a marked effect on the  $d$  constant, thus resulting in unpredictable variations across a single circuit board. It has been especially difficult to control the 5 displacement of the actuator, in the case of a laminated piezoelectric element having a plurality of displacement elements mounted on a single circuit board.

According the present invention, in contrast, piezoelectric characteristic can be stabilized by improving the wettability of the silver-palladium (Ag-Pd) electrodes and the piezoelectric ceramic layer, thereby increasing the bonding strength between these 10 members. When an actuator consisting of the laminated piezoelectric element of the present invention shown in Fig. 1 is driven with an alternate signal having frequency of 20KHz, for example, stable displacement is achieved and the problem of the prior art that oscillation stops in three hours can be solved.

According to the present invention, it is important to use a silver-palladium alloy 15 containing 71 to 99.9% by volume of silver and 0.1 to 29% by volume of palladium as the electrodes, in order to increase the bonding strength between the electrodes and the piezoelectric ceramic layer. The electrode having such a composition has better wettability with the piezoelectric ceramic material and is expected to improve the bonding strength between these members.

20 In order to further decrease the residual stress between the piezoelectric ceramic layer 1 and the electrodes 2, 3, lower limit of the silver content in the electrodes 2, 3 is preferably 80% by volume, more preferably 85% by volume, and most preferably 90% by volume. Upper limit of the silver content is 99.9% by volume, preferably 97% by volume, and more preferably 95% by volume.

25 Also according to the present invention, the electrodes made by simultaneous

firing preferably comprises a silver-palladium alloy containing 87% or more by volume, preferably 90% or more by volume and most preferably 93% or more by volume of silver, while controlling the residual stress remaining in the actuator after firing within 100MPa, preferably within 85MPa and most preferably 70MPa. By controlling the silver content 5 in the electrode to not less than 87% by volume, such a remarkable effect can be expected as the compressive stress due to shrinkage of the electrode is reduced. Also by controlling the residual stress in the actuator within 100MPa, it is made possible to suppress the decrease in capacitance of the piezoelectric ceramic layer and prevent the displacement of the displacement element from decreasing.

10 In order to further increase the bonding strength and reduce the residual stress thereby improving the stability of the piezoelectric characteristic further, it is preferable that at least a part of the electrodes, particularly the internal electrode 2, contains the piezoelectric ceramic material. In order to increase the bonding strength between the piezoelectric ceramic layer 1 and the electrodes while reducing the residual stress, 15 proportion of the piezoelectric ceramic material is preferably from 16 to 60% by volume of the silver-palladium alloy, more preferably from 18 to 50% by volume and most preferably from 20 to 30% by volume.

In order to achieve uniform distribution of the residual stress, it is preferable that the piezoelectric ceramic material has mean crystal grain size of  $0.9 \mu m$  or less, more 20 preferably  $0.7 \mu m$  or less and most preferably  $0.6 \mu m$  or less. When the crystal grain size is controlled in the range described above, residual stress, if ever exists, is distributed uniformly among the plurality of displacement elements, thereby minimizing the influence on the displacement characteristic through the reduction in the variation of the residual stress.

25 In the laminated piezoelectric element of the present invention, when a voltage is

applied between the internal electrode 2 and the surface electrode 3, the piezoelectric ceramic layer 1 interposed between the electrodes displaces. In case a plurality of displacement elements are formed on a single circuit board, it is made possible to use a low-cost IC for controlling the displacement element by suppressing the variations in the d constant are preferably within  $\pm 10\%$  across the surface, thereby reducing the cost of the unit including the actuator. In the laminated piezoelectric element of the present invention, since residual stress is reduced by increasing the bonding strength of the electrodes and the piezoelectric ceramic layer, the variations in the d constant can be controlled within  $\pm 10\%$  across the surface

10 In addition, by setting the bonding strength between the internal electrode 2 and the piezoelectric ceramic layer 1 to 1.25MPa or higher, preferably to 2MPa or higher and more preferably to 5MPa or higher, stable piezoelectric characteristic can be obtained and it is made possible to suppress exfoliation of the piezoelectric ceramic layer 1 and the electrodes 2, 3 that would lead to failure of driving, when driving the actuator.

15 By combining the silver-palladium alloy and the piezoelectric ceramic layer 1, it is made possible to suppress the deformation of the laminated piezoelectric element and the variations of the d constant across the surface, thereby to obtain the laminated piezoelectric element that allows easy control of the displacement. The laminated piezoelectric element of the present invention can be applied particularly preferably to a 20 device having a plurality of displacement elements mounted on a single circuit board. This constitution has an advantage of making it easier to control the displacement and allow the use of a low-cost IC.

25 In the present invention, the term piezoelectric ceramic material refers to a ceramic material that shows piezoelectricity, such as Bi layer compound, material having tungsten-bronze structure, alkali niobate compound of perovskite structure, lead zirconate

titanate (PZT) containing Pb and compound of perovskite structure containing lead titanate. Among these materials, lead zirconate titanate containing Pb and lead titanate are particularly preferable for improving the wettability and hence the bonding strength with the electrodes.

5 Specifically, a crystal containing Pb as a constituent element at site A and Zr and/or Ti as constituent element at site B, and especially made of a lead zirconate titanate-based compound is preferable for obtaining a stable sintered piezoelectric material that has higher d constant.

It is also preferable that the piezoelectric ceramic layer 1 contains at least one kind 10 selected from among Sr, Ba, Ni, Sb, Nb, Zn and Te, which enables it to obtain the laminated piezoelectric element having higher stability. Specifically, one made by solid solution of auxiliary components  $Pb(Zn_{1/3}Sb_{2/3})O_3$  and  $Pb(Ni_{1/2}Te_{1/2})O_3$  may be used.

It is particularly desirable to further include an alkali earth element as the 15 constituent element at site A. As the alkali earth element, Ba and Sr are particularly preferable since they enable it to achieve greater displacement. It is advantageous to include 0.02 to 0.08 moles of Ba and 0.02 to 0.12 moles of Sr for achieving a large displacement in case the composition is dominated by tetragonal crystal system.

Specifically, for example, a material having composition of 20  $Pb_{1-x-y}Sr_xBa_y(Zn_{1/3}Sb_{2/3})_a(Ni_{1/2}Te_{1/2})_bZr_{1-a-b-c}Ti_cO_3 + \alpha wt\% Pb_{1/2}NbO_3$  ( $0 \leq x \leq 0.14$ ,  $0 \leq y \leq 0.14$ ,  $0.05 \leq a \leq 0.1$ ,  $0.002 \leq b \leq 0.01$ ,  $0.44 \leq c \leq 0.50$ ,  $\alpha = 0.1 \sim 1.0$ ) may be used.

Now the method of manufacturing the laminated piezoelectric element of the present invention will be described below in the case of using PZT as the piezoelectric ceramic material, by way of example.

First, PZT powder having purity of 99% and mean particle size of  $1 \mu m$  or less is 25 prepared as the material to make the piezoelectric ceramic material.

A mixture of the piezoelectric ceramic powder and an organic binder is formed into the shape of tape, to make a plurality of green sheets. Some of the green sheets are coated with an Ag-Pd paste that makes the internal electrode on part thereof, with the green sheets being stacked one on another and cut into a desired shape. These laminates are 5 heated to around 400°C to remove the binder, and then fired at a temperature from 900 to 1050°C. Then the surface electrode is formed on the surface, and the piezoelectric ceramic layer between the internal electrodes and the surface electrode is subjected to polarization, thereby to complete the laminated piezoelectric element.

When fabricating the laminate of the green sheets, it is preferable to attach 10 constraint sheet, that comprises the piezoelectric ceramic material of substantially the same composition as that of the green sheet and an organic composition, on one or both of the laminate and pressed together. Restricting the outside green sheet from shrinking by means of the constraint sheet has an effect of suppressing the warp of the laminate, thus enabling it to reduce the stress generated therein when bonding it with a supporting 15 substrate.

Density of the green sheet before sintering is preferably 4.5g/cm<sup>2</sup> or higher. By increasing the density of the sintered material to 4.5g/cm<sup>2</sup> or higher, it is made possible to sinter at a lower temperature. When the density of the green sheet is increased further, Pb can be restricted from evaporating.

20 The actuator of the present invention is provided with the laminated piezoelectric element described above, and is featured by the capability to make a large displacement. It is particularly preferable that the laminated piezoelectric element described above is bonded onto the supporting substrate.

25 The actuator of the present invention has a plurality of displacement elements mounted on a single circuit board, and can be preferably applied to an ink jet printing head

used in an apparatus that utilizes the ink jet technology.

In the ink jet printing head shown in Fig. 2(a), (b), for example, an actuator 15 is bonded to a flow passage member 16 that has a plurality of ink compressing chambers 16a having ink nozzles 18 and a partition walls 16b that separate the ink compressing chambers

5 16a. Thus this printing head has such a constitution as the actuator 15 is placed on the flow passage member 16 wherein the plurality of ink compressing chambers 16a having the ink nozzles 18 are arranged, with the ink compressing chambers 16a and the surface electrode 13 being aligned with each other.

The actuator 15 is made by forming the internal electrode 12 on one of the  
10 principal surfaces of the piezoelectric ceramic layer 11b, forming the surface electrode 13 on the other principal surface, and forming the displacement elements 14, that comprise the surface electrode 13, the internal electrode 12 and piezoelectric ceramic layer 11a interposed between these electrodes, on an oscillator plate 11.

Specifically, the actuator 15 comprising the internal electrode 12, the piezoelectric  
15 ceramic layer 11b having a thickness of  $50 \mu \text{ m}$  or less and the surface electrode 13 that are stacked in this order on the oscillator plate 11a, and a plurality of the surface electrodes 13 that are disposed on the surface of the piezoelectric ceramic layer 11b, is bonded onto the flow passage member 16 so that the surface electrodes 13 are located right above the ink compressing chambers 11. The above piezoelectric ceramic material can be used as the  
20 oscillator plate 11a.

With this printing head, when a voltage is applied by a drive circuit between one of the surface electrodes 13 and the internal electrode 12, the piezoelectric ceramic layer 11b located right below the particular surface electrode 13 is displaced so as to apply a pressure to the ink in the ink compressing chamber 13a, so that a drop of ink is discharged  
25 from an ink outlet orifice 18 that opens at the bottom of the flow passage member 16.

By using the laminated piezoelectric element of the present invention as the actuator of the printing head, the printing head can be made by using a low-cost IC.

The printing head according to the present invention has better displacement characteristic that enables it to discharge the ink at a higher speed with higher precision, 5 and is preferably used for high speed printing. A printer that comprises the printing head according to the present invention, an ink tank which supplies ink to the printing head and a paper transfer mechanism is capable of printing at a higher speed with higher precision more easily than the prior art.

The following examples illustrate the manner in which the present invention can 10 be practiced. It is understood, however, that the examples are for the purpose of illustration and the invention is not to be regarded as limited to any of the specific materials or condition therein.

### Example 1

15 The laminated piezoelectric element of the present invention was fabricated and was applied to an ink jet printing head as an actuator.

First, a powder of piezoelectric ceramic material containing lead zirconate titanate (PZT) having purity of 99% or higher was prepared as the starting material.

The piezoelectric ceramic powder was mixed with butyl methacrylate used as an 20 aqueous binder, ammonium polycarbonate used as a dispersant and isopropyl alcohol and water used as solvents, to obtain a slurry. The slurry was spread over a carrier film by means of a doctor blade, so as to form a green sheet having a thickness of  $30 \mu \text{m}$ .

Then a paste to form the internal electrode was made by mixing a Ag-Pd alloy containing silver and palladium in proportions shown in Table 1 and the piezoelectric 25 ceramic powder containing PZT as the main component, thereby to obtain the composition

of the internal electrode shown in Table 1. The Ag-Pd alloy and the piezoelectric ceramic powder were added to separate vehicles that contained organic binder and organic solvent, and were well mixed to obtain the paste to make the internal electrode.

The paste was applied to the surface of the green sheet to a thickness of  $4 \mu \text{m}$  by 5 printing, thereby forming the internal electrode. Then, two green sheets without any internal electrode, the green sheet with the internal electrode on the surface, and the green sheet without any internal electrode were stacked in this order, and pressed to make a laminate.

The laminate, after being degreased, was sintered by keeping at the sintering 10 temperature shown in Table 1 for two hours in an atmosphere having oxygen concentration of 99% or higher, thereby making a sintered laminate consisting of the piezoelectric ceramic layer 1 and the internal electrodes 2. Then the surface electrode 3 was formed on one surface of the sintered laminate by applying Au paste by the screen printing process and firing at a temperature from 600 to 800°C in air atmosphere. 600 points of the 15 surface electrode 3 were formed on one substrate.

Last, lead wires were connected to the surface electrodes 3 by soldering, thus completing the laminated piezoelectric element having the configuration shown in Fig. 1.

Samples used in measuring the  $d$  constant and bonding strength were fabricated as described below. The laminated piezoelectric element made as described above was 20 formed into 10cm square, that was polished only on one side thereof, leaving only one layer of the piezoelectric ceramic material. Electrodes were formed by vapor deposition of Au on both surfaces of this ceramic sheet. The ceramic sheet was then cut into strips measuring 12mm by 3mm by dicing, and the strips were subjected to polarization by applying DC voltage of 3kv/mm in silicone oil. Resonance frequency, antiresonance 25 frequency, resonance resistance, antiresonance resistance and capacitance of the elements

thus obtained were measured using an impedance analyzer (Agilent Technologies' model 4194A), and the value of d31 was determined using a value of density determined by Archimedes' method. The values of d31 were averaged and maximum percent deviation from the mean value was taken as the variation of d31.

5 Displacement was measured using the setup shown in Fig. 3, wherein the actuator comprised a plurality of displacement elements 24, that were made by interposing the piezoelectric ceramic layer 21b between the surface electrode 23 and the internal electrodes 22, disposed on an oscillator plate 21a, with the actuator being bonded onto a supporting member 26 having grooves 26a and partition walls 26b.

10 The actuator was irradiated with laser beam on the side where the groove 26a are formed by means of a laser Doppler displacement meter, so as to measure displacements at the center and seven points along the periphery of the groove 26a, and the displacements were averaged.

15 Electrode resistance was measured between two VIA electrodes connected to the internal electrodes using the impedance analyzer (Agilent Technologies' model 4194A) at 25°C.

For the bonding strength, tensile test was conducted on the laminate from which the binder has not been removed, having partial electrode measuring 2mm by 2mm made of the same material as that of the internal electrode printed thereon, that was fired under 20 the same conditions as described above, then a Cu wire 0.8mm in diameter was connected to the partial electrode measuring 2mm by 2mm by soldering. The test result is shown in Table 1.

Table 1

Sample No.	Internal electrode composition				Thickness		Firing temp.	Variations of d31	Displacement	Electrode resistance	Bonding strength					
	Ag-Pd alloy		Ceramic powder		Each component layer	Total										
	Ag	Pd	Content	grain size												
	% by volume	% by volume	% by volume	μm	μm	μm	°C	%	nm	Ω	MPa/mm <sup>2</sup>					
1	99.9	0.1	25	0.5	25	100	900	2	85	2	14.2					
2	97	3	25	0.5	25	100	950	2	86	2	15.1					
3	95	5	25	0.5	25	100	960	2	85	2	14.1					
4	90	10	25	0.5	25	100	1000	2	85	2	15.2					
5	85	15	25	0.5	25	100	1000	2	85	2	13.1					
6	80	20	25	0.5	25	100	1000	3	86	2	10.1					
7	75	25	25	0.5	25	100	1000	5	85	2	5.2					
* 8	70	30	25	0.5	25	100	1000	11	86	2	1.1					
* 9	65	35	25	0.5	25	100	1000	15	85	2	0.4					
10	80	20	10	0.5	25	100	1000	10	85	2	5.1					
11	80	20	16	0.5	25	100	1000	3	86	2	6.2					
12	80	20	20	0.5	25	100	1000	2	85	2	7.1					
13	80	20	30	0.5	25	100	1000	2	85	2	14.1					
14	80	20	40	0.5	25	100	1000	2	85	2	14.1					
15	80	20	50	0.5	25	100	1000	2	86	2	15.2					
16	80	20	60	0.5	25	100	1000	2	85	2	15.1					
17	80	20	70	0.5	25	100	1000	2	86	30	15.2					
18	80	20	80	0.5	25	100	1000	2	86	1000	14.1					
19	80	20	25	0.6	25	100	1000	3	86	2	10.1					
20	80	20	25	0.8	25	100	1000	3	86	2	10.3					
21	80	20	25	0.9	25	100	1000	3	86	2	10.2					
22	80	20	25	1.0	25	100	1000	10	85	2	10.3					
23	80	20	25	0.5	12	48	1000	2	85	2	10.1					
24	80	20	25	0.5	15	60	1000	2	86	2	10.2					
25	80	20	25	0.5	18	72	1000	2	85	2	10.1					
26	80	20	25	0.5	20	80	1000	2	86	2	10.1					
27	80	20	25	0.5	25	100	1000	2	85	2	10.2					
* 28	80	20	25	0.5	30	1000	1000	2	20	2	10.1					

Sample numbers marked with \* are not within the scope of the present invention.

(the variations of d31) = { M / (the mean value of d31) } × 100

[M is maximum difference between the value of d31 and the mean value of d31.]

Samples Nos. 1 to 7 and Nos. 10 to 27 of the present invention were laminated piezoelectric elements showing variations of d<sub>31</sub> within 10% and bonding strength of 5MPa/mm<sup>2</sup> or higher, allowing it to easily control the displacement.

Samples Nos. 8 and 9, out of the scope of the present invention, that contained 5 70% by volume or less silver showed significant variation in d<sub>31</sub> of 11% or more and low bonding strength of 1.26MPa/mm<sup>2</sup> or less.

Sample No. 28, out of the scope of the present invention, having a total thickness of 1000  $\mu$  m (1mm) showed very low displacement characteristic with a low displacement of 20nm.

10

### Example 2

High purity powders of Pb<sub>2</sub>O<sub>3</sub>, ZrO<sub>2</sub>, TiO<sub>2</sub>, BaCO<sub>3</sub>, ZnO, SrCO<sub>3</sub>, Sb<sub>2</sub>O<sub>3</sub>, NiO, TeO<sub>2</sub> were prepared as the stock materials. Predetermined quantities of these powders were measured to obtain the compositions A1 to D1 described below after sintering.

[A1]: Pb<sub>1-x-y</sub>Sr<sub>x</sub>Ba<sub>y</sub>(Zr<sub>1/3</sub>Sb<sub>2/3</sub>)<sub>a</sub>(Ni<sub>1/2</sub>Te<sub>1/2</sub>)<sub>b</sub>Zr<sub>1-a-b-c</sub>Ti<sub>c</sub>O<sub>3</sub>(x = 0.04, y = 0.02, a = 0.075, b =

15 0.005, c = 0.45)

[B1]: Pb(Zn<sub>1/3</sub>Sb<sub>2/3</sub>)<sub>0.075</sub>(Ni<sub>1/2</sub>Te<sub>1/2</sub>)<sub>0.005</sub>Zr<sub>0.47</sub>Ti<sub>0.45</sub>O<sub>3</sub>

[C1]: PbZr<sub>0.5</sub>Ti<sub>0.5</sub>O<sub>3</sub>

[D1]: BaTiO<sub>3</sub>

The predetermined quantities of the powders measured as described above were 20 mixed in wet process in a ball mill for 20 hours, and the mixture was dewatered and dried. The dried mixture was calcined at 900°C for three hours, and the calcined material was crushed in wet process in a ball mill.

The crushed material was mixed with an organic binder, water, a dispersant and a plasticizer to make a slurry. The slurry was formed into a sheet by the roll coater process 25 that is commonly employed when forming a thin green sheet, thereby making a green sheet.

The thickness of the green sheet was set by taking the shrinkage ratio into consideration so that the thickness shown in Table 2 could be achieved after firing.

The green sheet was punched through using a die to make a plurality of rectangular sheets. The paste containing the Ag-Pd alloy was applied to the surface of the 5 rectangular sheets by screen printing, thereby forming the internal electrodes and the surface electrodes.

The green sheets coated with the electrode paste and the green sheets without the electrode paste were stacked one on another as shown in Fig. 1, and were pressed while heating so as to fuse together, thereby making the laminate.

10 After degreasing the laminate at 400°C, the laminate was fired under the conditions shown in Table 1 for two hours, thereby making the actuator.

After polishing the cross section of the ceramic layers, the thickness of the actuator was measured by means of a microscope. Bonding of the piezoelectric ceramic layer and the electrodes was visually checked to see if there was exfoliation.

15 Residual stress in the actuator was measured by means of X-ray diffraction with characteristic X-ray of Fe and diffraction peak of 126°, using collimator having diameter of 2mm. Residual stress is given with a negative sign if it is a compressive stress.

Displacement was measured similarly to Example 1, with the results shown in Table 2.

Table 2

Sample No.	Piezoelectric ceramic layer	Internal electrode composition		Condition of firing		Thickness		Actuator			Exfoliation of the electrodes
		Ag	Pd	temp.	Oxygen concentration	Each component layer	Total	Residual stress	Displacement		
		kind	% by volume	% by volume	°C	%	μm	μm	MPa	nm	
29	A1	70	30	1000	98	11	60	-150	22	no	
30	A1	80	20	1000	98	11	60	-110	48	no	
31	A1	87	13	1000	98	11	60	-90	60	no	
32	A1	90	10	1000	98	11	60	-70	72	no	
33	A1	93	7	980	98	11	60	-55	80	no	
34	A1	95	5	960	98	11	60	-50	82	no	
35	A1	97	3	950	98	11	60	-30	77	no	
36	A1	99	1	930	98	11	60	-20	70	no	
37	A1	90	10	1000	98	60	50	-100	40	no	
38	A1	90	10	1000	98	50	50	-90	50	no	
39	A1	90	10	1000	98	20	50	-80	60	no	
40	A1	90	10	1000	98	15	50	-75	70	no	
41	A1	90	10	1000	98	5	50	-67	75	no	
42	A1	90	10	1000	98	3	50	-70	80	no	
43	A1	90	10	950	98	11	45	-78	68	no	
44	A1	90	10	900	98	11	45	-80	65	no	
45	A1	90	10	1000	95	11	50	-80	68	no	
46	B1	90	10	1000	98	11	50	-80	55	no	
47	C1	90	10	1000	98	11	50	-75	50	no	
48	D1	90	10	1000	98	11	50	-80	30	no	
* 49	A1	90	10	1000	98	20	200	-85	15	no	

Sample numbers marked with \* are not within the scope of the present invention.

A1:  $\text{Pb}_{0.94}\text{Sr}_{0.04}\text{Ba}_{0.02}(\text{Zn}_{1/3}\text{Sb}_{2/3})_{0.075}(\text{Ni}_{1/2}\text{Te}_{1/2})_{0.005}\text{Zr}_{0.47}\text{Ti}_{0.45}\text{O}_3$

B1:  $\text{Pb}(\text{Zn}_{1/3}\text{Sb}_{2/3})_{0.075}(\text{Ni}_{1/2}\text{Te}_{1/2})_{0.005}\text{Zr}_{0.47}\text{Ti}_{0.45}\text{O}_3$

C1:  $\text{PbZr}_{0.5}\text{Ti}_{0.5}\text{O}_3$

D1:  $\text{BaTiO}_3$

Table 2 shows that samples Nos. 29 to 45 of the present invention having composition A1 showed displacements of 20nm or larger. Samples Nos. 31 to 45 having Ag content of 87% by volume or higher and residual stress of 100MPa or less showed displacements of 40nm or larger. Samples Nos. 32 to 36 and Nos. 39 to 45 having residual stress of 85MPa or less, in particular, showed displacements of 60nm or larger. Samples Nos. 32 to 36 and Nos. 40 to 42 having residual stress of 75MPa or less showed displacements of 70nm or larger.

5 Samples Nos. 46 to 48 of the present invention having compositions B1, C1 and D1 showed displacements of 30nm or larger.

10 Samples No. 49 having composition A1 but 200  $\mu$  m thick, in contrast, showed small displacement of 15nm.